

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Matthew J. Breitwisch, et al. **Examiner:** Douglas W. Owens
Serial No.: 10/710,821 **Art Unit:** 2811
Filed: August 5, 2004 **Docket:** BUR920040015US1 (17427)

For: ISOLATED FULLY DEPLETED SILICON-ON-INSULATOR REGIONS BY
SELECTIVE ETCH

Confirmation No. 6753 **Dated:** October 16, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO EX PARTE OUAYLE OFFICE ACTION

Sir:

In response to the *Ex Parte Quayle* Office Action dated September 13, 2006, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATION OF ELECTRONIC TRANSMISSION

I hereby certify that this paper is being electronically transmitted to the Patent and Trademark Office on the date shown below.

Dated: October 16, 2006



Leslie S. Szivos